



Attorney Docket No. 81329A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the application of: JOSEPH J. DANKO

Serial No: 09/579,593

Group Art Unit: 2877

Filed: May 26, 2000

Examiner: G.J. Stock, Jr.

For: METHOD AND APPARATUS FOR INSPECTING A PATTERNED
SEMICONDUCTOR WAFER

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

AMENDMENT AFTER FINAL REJECTION

This communication is in response to an Office Action received on this application dated September 3, 2003. It is respectfully requested that the above-identified application be amended as follows:

There are no Amendments to the Specification or Drawings in this paper.

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.

OK
To
GJER
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3/15/04